



Docket No. 1232-5299

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kenji Yamazoe et al.

Group Art Unit: TBA

Serial No.: 10/783,218

Examiner: 1756

Filed: February 20, 2004

For: MASK AND ITS MANUFACTURING METHOD, EXPOSURE, AND DEVICE
FABRICATION METHOD

EXPRESS MAIL CERTIFICATE

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Commissioner for Patents
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Date of Deposit: October 14, 2004

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